



REPLY UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 2851

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION OF

Confirmation No.: 2940

SEGRS et al.

Group Art Unit: 2851

Appln. No.: 09/552,672

Examiner: Fuller, Rodney Evan

Filed: April 19, 2000

Title: LITHOGRAPHIC PROJECTION APPARATUS

June 23, 2003

(June 21, 2003 falls on Saturday)

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AMENDMENT AFTER FINAL UNDER 37 C.F.R. § 1.116

Hon. Commissioner of Patents
Washington, D.C. 20231

RECEIVED
JUN 26 2003
TC 2800 MAIL ROOM

Sir:

In reply to the Office Action dated March 21, 2003, please amend the above identified application as follows:

IN THE CLAIMS:

Please cancel claim 20 without prejudice or disclaimer.

Please enter amended claims 12 and 21 as follows:

12. (Three Times Amended) A substrate preparing device comprising an intermediate table on which a substrate can be positioned before transfer to a substrate table in a lithographic projection apparatus;